@PFDesktop\::ODMA/MHODMA/HBSR05;iManage;593264;1

△OC/law
12/15/05

10/565353 IAP15 Rec'd PCT/PTO 20 JAN 2006 PATENT APPLICATION Attorney's Docket No.: 3194.1019-009

IN THE UNITED STATES RECEIVING OFFICE (RO/US) Designated/Elected Office (DO/EO/US)

U.S. National Stage of

International Application No.:

PCT/US2004/023491

International Filing Date:

21 July 2004

Earliest Priority Date:

21 July 2003

Applicants:

Daniel Alvarez, Jr., Jeffrey J. Spiegelman,

Joshua T. Cook, Tram Doan Nguyen, Daniel A. Lev

and Troy B. Scoggins

Title:

HYDRIDE GAS PURIFICATION FOR THE

SEMICONDUCTOR INDUSTRY

Attorney's Docket No.:

3194.1019-009

Date: 20 JANUARY ZOOG

EXPRESS MAIL LABEL NO. EV2148868 55 US

PRELIMINARY AMENDMENT

Mail Stop PCT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Please amend the application as follows: